



7-8-05

IFW

Express Mail No. **EV 346 792 936 US**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Walter SCHWARZENBACH et al.

Confirmation No. 9739

Application No.: 10/733,729

Group Art Unit: 2812

Filing Date: December 12, 2003

Examiner: D. NHU

For: **METHOD OF MAKING CAVITIES IN A  
SEMICONDUCTOR WAFER**

Atty. Docket No.: 4717-9200

**RESPONSE TO RESTRICTION**

Commissioner of Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Examiner's restriction requirement dated March 30, 2005,  
applicants elect method claims 1-14 of Group I for examination in this application.

No fees are believed to be due for this amendment. Should any fees be required,  
please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

4/7/05  
Date

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